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January 23, 2004

CERTIFICATE OF MAILING 37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS DD, Commissioner for Patents, P.O. Box 1450, Alexandria 1450, on the date below:

January 23, 2004

Date

Mark B. Wilson

MS DD

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

RE:

U.S. Patent Application No. 09/992,054 entitled "HIGH INDEX AND HIGH IMPACT RESISTANT POLYTHIOURETHANE/UREA MATERIAL, METHOD OF MANUFACTURING

SAME AND ITS USE IN THE OPTICAL FIELD" – Aref Ben Ahmed Jallouli et al.

Our reference: ESSR:058US

Client reference: N842M US 3829

Sir:

Enclosed for filing in the above-referenced patent application is a Supplemental Information Disclosure Statement, Form PTO-1449, and references A2-A3 and B1-B4.

A fee as set forth in 37 C.F.R. § 1.17(p) in the amount of \$180.00 is enclosed herewith. If an appropriate check has not been enclosed, or if it is insufficient, the Commissioner is authorized to deduct the appropriate fees from Fulbright & Jaworski L.L.P. Account No.: 50-1212/ESSR:058US.

Please date stamp and return the enclosed postcard evidencing receipt of these materials.

Respectfully submitted,

Reg. No. 37,259

MBW/kmv Encl.: as noted



in re Application of:

Aref Ben Ahmed Jallouli et al.

Serial No.: 09/992,054

Filed: November 14, 2001

For: HIGH INDEX AND HIGH IMPACT

RESISTANT

POLYTHIOURETHANE/UREA MATERIAL, METHOD OF

MANUFACTURING SAME AND ITS

USE IN THE OPTICAL FIELD

Group Art Unit: 1711

Examiner: Rabon A. Sergent

Atty. Dkt. No.: ESSR:058US

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January 23, 2004

Date

Mark B Wilson

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS DD

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

01/29/2004 SDENBOB1 00000060 09992054

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In accordance with 37 C.F.R §§ 1.97(g), (h), this Supplemental Information Disclosure

Statement is not to be construed as a representation that a search has been made, and is not to be

construed to be an admission that the information cited is, or is considered to be, material to

patentability as defined in 37 C.F.R. § 1.56(b).

A fee as set forth in 37 C.F.R. § 1.17(p) in the amount of \$180.00 is enclosed herewith.

If an appropriate check has not been enclosed, or if it is insufficient, the Commissioner is

authorized to deduct the appropriate fee from Fulbright & Jaworski Account No.: 50-

1212/ESSR:058US.

Applicants respectfully request that the listed documents be made of record in the present

case.

Respectfully submitted,

Mark B. Wilson Reg. No. 37,259

Attorney for Applicants

FULBRIGHT & JAWORSKI L.L.P. 600 Congress Avenue, Suite 2400 Austin, Texas 78701 (512) 474-5201

Date:

January 23, 2004

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Form PTO-1449 (modified)			Atty. Docket No.	Serial No.
			ESSR:058US	09/992,054
List of Patents and Publicati ns for Applicant's			Applicant	
OTP E INFOR	RMATION DISCLOSURE S	STATEMENT	Aref Ben Ahmed Jallou	li <i>et al</i> .
מחנ ען			Filing Date:	Group:
JAN 2 6 2004 H	(Use several sheets if necess	ary)	November 14, 2001	1711
	S. Patent Documents Foreign		Patent Documents	Other Art
See Page 1		See Page 1		See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A2	4,254,229	3/3/81	Schwindt et al.	521	163	12/26/79
	A3	6,100,362	8/8/00	Okazaki et al.	528	76	10/7/97

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	SU 1085991	4/15/84	Soviet Union			No
	B2	WO 01/36507	11/18/00	PCT			English
	В3	WO 01/36508	11/18/00	PCT			English
	B4	WO 01/70841	3/19/01	PCT			English

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation

25374664.1

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.